

Obducat receives order from University of Science and Technology of China

OBDUCAT, leading manufacturer of lithography solutions based on nanoimprint lithography (NIL), has signed a contract concerning the supply of an EITRE® 6 NIL system to University of Science and Technology of China (USTC). The order value is 400 KEUR, which was included in the order take in Q2 reporting.

The EITRE system will be installed in the Center for Micro- and Nanoscale Research and Fabrication, which is sponsored by USTC since 2010 and construction began in 2012. USTC is considered one of the top Universities in China and the Center is also one of the most important projects for USTC during the twelfth 5 year plan.

The Center has a 1200 m² clean room to be used for micro- and nanofabrication and characterization. The first phase of investment in equipment purchase is 40 million RMB and the second will be 50 million RMB. The plan is to create a public research platform for energy, information technology, medicine and environment in USTC. The Center will be one of the top facilities in China for public micro- and nanoresearch and fabrication.

The EITRE® 6 NIL system to University of Science and Technology of China system will be delivered during the fourth quarter this year.

We are very much honored that the highly regarded USTC has chosen Obducat as supplier of NIL technology. This installation marks our 19th installation in China which makes us the leading NIL supplier in China, says Patrik Lundström, CEO, Obducat.

This is information that Obducat AB (publ) is required to disclose pursuant to the Swedish Securities Market Act and/or the Financial Instruments Trading Act. The information was submitted for publication on August 25, 2014 at 14.30 CET.

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About Obducat AB (publ)

Obducat AB is an innovative developer and supplier of technologies, products and processes used for the production and replication of advanced micro and nano structures. Obducat's products and services serve the demands of companies within the information storage, semiconductor, printed circuit board, and sensor industries. Obducat's technologies include electron beam and nano imprint technology. Obducat has offices in Sweden and China, with the headquarter located in Lund, Sweden. The Obducat shares are publicly traded on the Swedish NGM stock exchange. Read more at www.obducat.com